

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q87054

Yasuki KIMURA

Appln. No.: 10/529,152

Group Art Unit: 1792

Confirmation No.: 1832

Examiner: Allan W. Olsen

Filed: March 24, 2005

For: METHOD OF ETCHING CHROMIUM THIN FILM AND METHOD OF PRODUCING  
PHOTOMASK

**SUPPLEMENTAL AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Supplemental to the Amendment Under 37 C.F.R. § 1.111 that was filed on May 15, 2008 in response to the Office Action dated November 15, 2007, please enter the enclosed Declaration Under Rule 132 of Yasuki KIMURA, the inventor in the present application.